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Legal Representative:

Attorney or Agent:

Eric J. Robinson

Registration Number:

38285

Attorney or Agent:

Jeffrey L. Costellia

Registration Number: 35483

Attorney or Agent:

Jason H. Vick

45285

Registration Number: Attorney or Agent:

Charles M. Leedom

26477

Registration Number: Attorney or Agent:

David S. Safran

Registration Number:

27997

Customer Number Correspondence Address:

22204

22204

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Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi 243-0036 Kanagawa-ken JP

INVENTOR(s):

Primary Citizenship:

JР

Given Name:

Shunpei

Family Name:

YAMAZAKI

Residence City:

Atsugi-shi

Residence Country:

JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Osamu

Family Name:

NAKAMURA

Residence City:

Atsugi-shi

Residence Country:

JΡ

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.



398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Masayuki KAJIWARA

Family Name:

Atsugi-shi

Residence City:
- Residence Country:

JΡ

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Junichi

Family Name:

KOEZUKA

Residence City:

Atsugi-shi

Residence Country:

JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Koji

Family Name:

DAIRIKI

Residence City:

Atsugi-si

Residence Country:

JΡ

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Toru

Family Name:

MITSUKI

Residence City:

Residence Country:

Atsugi-shi JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Toru

Family Name:

TAKAYAMA Atsugi-shi

Residence City: Residence Country:

JΡ

Address: c/o Semicor

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JΡ

Given Name:

Hideto

Family Name:

OHNUMA

- Residence City:

Atsugi-shi

Residence Country:

JΡ

` Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Taketomi

Family Name:

ASAMI

Residence City:

Atsugi-shi

Residence Country:

JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JΡ

Given Name:

Mitsuhiro

Family Name:

ICHIJO

Residence City:

Atsugi-shi

Residence Country:

JΡ

Address:

c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi Kanagawa-ken, 243-0036 JP